

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

JIN-TAE OH, ET AL.

Application No.:

Filed:

For: **High-Speed Pattern Storing and  
Matching Method**

Art Group:

Examiner:

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST FOR PRIORITY**

Sir:

Applicant respectfully requests a convention priority for the above-captioned application, namely:

| <u>COUNTRY</u> | <u>APPLICATION<br/>NUMBER</u> | <u>DATE OF FILING</u> |
|----------------|-------------------------------|-----------------------|
| Korea          | 2003-0087885                  | 5 December 2003       |

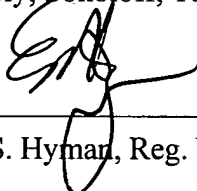
☐ A certified copy of the document is being submitted herewith.

Respectfully submitted,

Blakely, Sokoloff, Taylor & Zafman LLP

Dated: 12/31/03

12400 Wilshire Boulevard, 7th Floor  
Los Angeles, CA 90025  
Telephone: (310) 207-3800

  
Eric S. Hyman, Reg. No. 30,139